

Yin Zhifu

List of Publications by Year in descending order

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41
times ranked

189
citing authors

| # | ARTICLE | IF | CITATIONS |
|----|--|-----|-----------|
| 1 | Fabrication of PDMS chips by laser engraving for protein enrichments. Journal of Electrical Engineering, 2022, 73, 43-49. | 0.7 | 2 |
| 2 | Advances in 4D Printed Shape Memory Polymers: From 3D Printing, Smart Excitation, and Response to Applications. Advanced Materials Technologies, 2022, 7, . | 5.8 | 37 |
| 3 | Low Cost and Simple PMMA Nozzle Fabrication by Laser Cutting and PDMS Curing Bonding. International Journal of Precision Engineering and Manufacturing, 2021, 22, 139-146. | 2.2 | 4 |
| 4 | Trajectory analysis of the charged droplet during electrohydrodynamic jet printing. Microsystem Technologies, 2021, 27, 2935-2941. | 2.0 | 5 |
| 5 | The study on electric field distribution and droplet trajectory during electrohydrodynamic jet printing. Microsystem Technologies, 2021, 27, 2745-2750. | 2.0 | 3 |
| 6 | Numerical Study on the Electrohydrodynamic Jet Printing. Journal of Micro and Nano-Manufacturing, 2021, 9, . | 0.7 | 0 |
| 7 | The Fabrication of Polymethyl Methacrylate Nozzles for Electrohydrodynamic Printing. Journal of Nanoscience and Nanotechnology, 2021, 21, 1735-1741. | 0.9 | 2 |
| 8 | A Novel Room-Temperature Bonding Method Based on Electrohydrodynamic Printing. Journal of Nanoscience and Nanotechnology, 2021, 21, 1672-1677. | 0.9 | 0 |
| 9 | Fabrication of 2D silicon nano-mold by side etch lift-off method. Nanotechnology, 2021, 32, 285301. | 2.6 | 6 |
| 10 | A Simple and Low-Cost Method for Fabrication of Polydimethylsiloxane Microfluidic Chips. Journal of Nanoscience and Nanotechnology, 2021, 21, 5635-5641. | 0.9 | 0 |
| 11 | THE STUDY ON THE O ₂ PLASMA TREATMENT FOR BONDING OF SU-8 LAYERS. Surface Review and Letters, 2020, 27, 1950119. | 1.1 | 0 |
| 12 | Fabrication of SU-8 photoresist microfluidic chips by thermal imprinting and thermal bonding. Microsystem Technologies, 2020, 26, 861-866. | 2.0 | 7 |
| 13 | The fabrication of integrated and three-layer SU-8 nozzles for electrohydrodynamic printing. Microfluidics and Nanofluidics, 2020, 24, 1. | 2.2 | 2 |
| 14 | NUMERICAL STUDY ON BONDING OF PMMA NANOCANNELS. Surface Review and Letters, 2020, 27, 1950213. | 1.1 | 0 |
| 15 | A low-cost fabrication method of nanostructures by ultraviolet proximity exposing lithography. AIP Advances, 2020, 10, 045221. | 1.3 | 4 |
| 16 | The study of electrohydrodynamic printing by numerical simulation. Journal of Electrical Engineering, 2020, 71, 413-418. | 0.7 | 3 |
| 17 | Manufacture of microfluidic chips using a gap-control method based on traditional 3D printing technique. Microsystem Technologies, 2019, 25, 1043-1050. | 2.0 | 1 |
| 18 | An economic and concise method to solve nozzle clogging issue during electro hydrodynamic printing. International Journal of Modern Physics B, 2019, 33, 1950260. | 2.0 | 1 |

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|----|---|-----|-----------|
| 19 | New lithography technique based on electrohydrodynamic printing platform. <i>Organic Electronics</i> , 2019, 71, 279-283. | 2.6 | 11 |
| 20 | Structure-Induced Method for Circular Cross-Sectional Nanochannel Fabrication. <i>Journal of Nanoscience and Nanotechnology</i> , 2019, 19, 5750-5754. | 0.9 | 15 |
| 21 | A fast and simple bonding method for low cost microfluidic chip fabrication. <i>Journal of Electrical Engineering</i> , 2018, 69, 72-78. | 0.7 | 5 |
| 22 | A new low-cost fabrication method of SU-8 microfluidic channels and needle tip in electro-hydrodynamic jet chips. <i>Journal of Micromechanics and Microengineering</i> , 2018, 28, 115015. | 2.6 | 3 |
| 23 | Rapid prototyping of PET microfluidic chips by laser ablation and water soaking bonding method. <i>Micro and Nano Letters</i> , 2018, 13, 1302-1305. | 1.3 | 11 |
| 24 | Residual stress release for SU-8 structures by water assist ultrasonic. <i>Microsystem Technologies</i> , 2018, 24, 3141-3147. | 2.0 | 5 |
| 25 | A novel bonding method for fabrication of PMMA nanofluidic chip with low deformation of the nano-trenches. <i>Microfluidics and Nanofluidics</i> , 2018, 22, 1. | 2.2 | 4 |
| 26 | SU-8 nano-nozzle fabrication for electrohydrodynamic jet printing using UV photolithography. <i>Materials Science in Semiconductor Processing</i> , 2018, 84, 144-150. | 4.0 | 15 |
| 27 | Fast Microfluidic Chip Fabrication Technique by Laser Erosion and Sticky Tape Assist Bonding Technique. <i>Journal of Nanoscience and Nanotechnology</i> , 2018, 18, 4082-4086. | 0.9 | 8 |
| 28 | Polycarbonate Nanofluidic Chip Fabrication Technique by Hot Embossing and Thermal Bonding. <i>Journal of Nanoscience and Nanotechnology</i> , 2018, 18, 2530-2535. | 0.9 | 2 |
| 29 | Numerical study on the shrinkage behavior of SU-8 patterns. <i>Microsystem Technologies</i> , 2017, 23, 4957-4964. | 2.0 | 1 |
| 30 | A novel SU-8 nanofluidic chip fabrication technique based on traditional UV photolithography. <i>Microsystem Technologies</i> , 2017, 23, 5613-5619. | 2.0 | 2 |
| 31 | A waveform design method for high DPI piezoelectric inkjet print-head based on numerical simulation. <i>Microsystem Technologies</i> , 2017, 23, 5365-5373. | 2.0 | 20 |
| 32 | Multilayer patterning technique for micro- and nanofluidic chip fabrication. <i>Microfluidics and Nanofluidics</i> , 2017, 21, 1. | 2.2 | 8 |
| 33 | Effect of Gd doping on crystalline orientation, structural and electric properties of PZT thin films prepared by Sol-Gel methods. <i>Integrated Ferroelectrics</i> , 2017, 183, 100-109. | 0.7 | 3 |
| 34 | Fabrication of Bottom Fillet Nano-Mold to Increase the Mold Lifetime. <i>Journal of Nanoscience and Nanotechnology</i> , 2017, 17, 8975-8980. | 0.9 | 0 |
| 35 | Experimental and Numerical Study on PDMS Collapse for Fabrication of Micro/Nanochannels. <i>Journal of Electrical Engineering</i> , 2016, 67, 414-420. | 0.7 | 1 |
| 36 | Low autofluorescence fabrication methods for plastic nanoslits. <i>IET Nanobiotechnology</i> , 2016, 10, 75-80. | 3.8 | 3 |

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|----|--|-----|-----------|
| 37 | Optimization of the profile of the nano-mold and the imprinting conditions by numerical simulation method. <i>Microsystem Technologies</i> , 2016, 22, 1105-1113. | 2.0 | 2 |
| 38 | Surface modification-assisted bonding of 2D polymer-based nanofluidic devices. <i>Microfluidics and Nanofluidics</i> , 2015, 18, 527-535. | 2.2 | 12 |
| 39 | Analysis of polymer viscoelastic properties based on compressive creep tests during hot embossing for two-dimensional polyethylene terephthalate nanochannels. <i>Polymer Engineering and Science</i> , 2014, 54, 2398-2406. | 3.1 | 10 |
| 40 | Fabrication of two dimensional polyethylene terephthalate nanofluidic chip using hot embossing and thermal bonding technique. <i>Biomicrofluidics</i> , 2014, 8, 066503. | 2.4 | 17 |
| 41 | A novel hybrid patterning technique for micro and nanochannel fabrication by integrating hot embossing and inverse UV photolithography. <i>Lab on A Chip</i> , 2014, 14, 1614-1621. | 6.0 | 43 |